INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 29, 2026

IGI Report Number	LG853634796
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	8.70 X 8.68 X 5.69 MM

GRADING RESULTS

Carat Weight	4.01 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	VERY GOOD

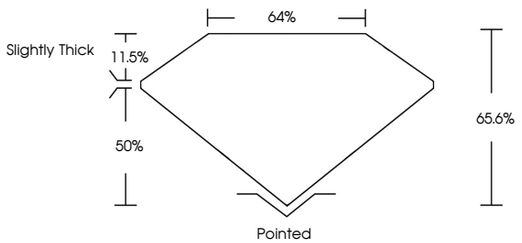
ADDITIONAL GRADING INFORMATION

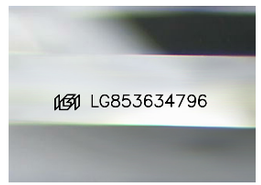
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG853634796

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG853634796
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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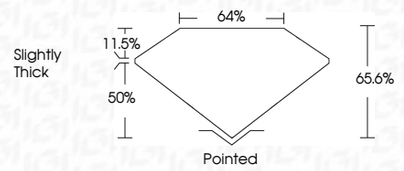
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IGI

October 29, 2026
IGI Report No LG853634796
SQUARE EMERALD CUT
8.70 X 8.68 X 5.69 MM
Carat Weight 4.01 CARATS
Color Grade E
Clarity Grade VS 1
Cut Grade VERY GOOD
Depth 65.6%
Table 64%
Girdle Slightly Thick
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG853634796
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa